

| Search Notes  | Application/Control No. | Applicant(s)/Patent under Reexamination |
|--|-------------------------|---|
| | 10/830,095 | ONO, SEIICHI |
| Examiner | Art Unit | |
| John Fitzgerald | 2856 | |

| INTERFERENCE SEARCHED | | | |
|-----------------------|----------|------|----------|
| Class | Subclass | Date | Examiner |
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